



PATENT

Customer No. 22852

Attorney Docket No. 8071.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Takeshi MITSUISHI et al.) Group Art Unit: 2872
)
Application No.: 09/986,907) Examiner: Joshua Pritchett
)
Filed: November 13, 2001)
)
For: COMPOSITION FOR VAPOR)
DEPOSITION, METHOD FOR)
FORMING AN ANTIREFLECTION)
FILM, AND OPTICAL ELEMENT)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

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JUN - 6 2003
TECHNOLOGY CENTER 2800

REPLY

This reply is filed in response to the non-final Office Action of March 24, 2003.
Prompt and favorable reconsideration of this application in light of the remarks below is respectfully requested.

REMARKS

Claims 1-17 remain pending in this application. Applicants acknowledge, with appreciation, the indication that claims 3-8 are directed to allowable subject matter, and would be allowable if rewritten in independent form.

To the extent that claims 9-17 depend, either directly or indirectly, on the subject matter of claims 6 or 8, we believe that these claims also should have been indicated to be allowable. A process of making an antireflection film from a composition that is both

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